

PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiromi OTOMA

Group Art Unit: 2821

Application No.: 10/826,354

Examiner: C. TRAN

Filed: April 19, 2004

Docket No.: 119498

For: SURFACE EMITTING SEMICONDUCTOR LASER AND COMMUNICATION
SYSTEM USING THE SAME

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the May 16, 2006 Office Action, please consider the following:

Amendments to the Specification; and

Remarks.

if Approved ??

Please enter

Thank's

T. C
09/08/06